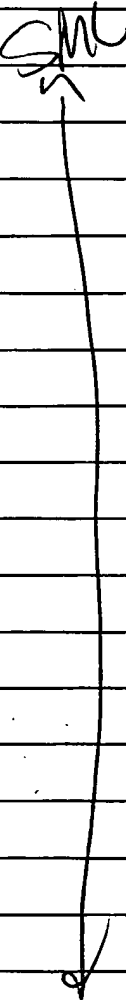


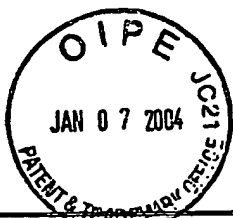
Form PTO-1449 (Rev. 6-98) U.S. Department of Commerce Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Attorney Docket No. 75252-022	Serial No. 10/678,253
	Applicant David L. Johnson et al.	
	Filing Date October 3, 2003	Group Art Unit Not yet assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub Class	Translation
	2002/0160309	10/31/2002	Pang et al.			
	2002/0106584	08/08/2002	Lawton et al.			
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	2001/0046642	11/29/2001	Johnson et al.			
	6,537,729	03/25/2003	Lawton			
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Examiner Initial	Document Number	Date	Name	Class	Sub Class	Translation
SML ↑	6,376,571	04/23/2002	Chawla et al.			
	6,362,249	03/26/2002	Chawla			
	6,355,599	03/12/2002	Zahora et al.			
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SML ↓	5,461,088	10/24/1995	Wolf et al.			

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Attorney Docket No.

75252-022

Serial No.

10/678,253

Applicant

David L. Johnson et al.

Filing Date

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Group Art Unit

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SMC	5,456,984	10/10/1995	Bishop et al.			
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	5,336,563	08/09/1994	Coady et al.			
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SMC	EP 0646580	4/ 5/1995	EPO			No
	English Abstract of EP 0646580	4/ 5/ 1995	EPO			Yes
	EP 0360869	4/ 4/1990	EPO			Yes
	EP 0162304	11/27/1985	EPO			Yes
SMC	JP 02 75618	3/15/1990	JPO			No

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SMC

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				Applicant David L. Johnson et al.			
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Examiner Initial	Document Number	Date	Name	Class	Sub Class	Translation	
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Examiner Initial	Document Number	Date	Country	Class	Sub Class	Translation	
SML	Translation of JP 0275618	3/15/1990	JPO			Yes	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
SML	Paul F. Jacobs, <u>Stereolithography and Other RP&M Technologies</u> 33-35 (ASME Press 1996)						
	Christian Decker & Khalil Moussa, <u>Kinetic study of the cationic photopolymerisation of epoxy monomers</u> , 28 J. Polym. Sci, Polym. Chem. 3429-43 (1990)						
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	Andreas Harwig, <u>Influence of moisture present during polymerisation on the properties of a photocured epoxy resin</u> 22 Int'l J. of Adhesion & Adhesives 409-414 (2002)						
SML	Piotr Penczek et al., <u>Epoxy polyesters as Film-Forming Materials</u> 187 Macromol. Symp. 243-244 (2002)						
Examiner SML				Date Considered 1/17/04			
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP§60 : Draw line through citation if not in conformance and not considered, include copy of this form with next communication to the patent owner.							

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Attorney Docket No.
75252-022

Serial No.
10/678,253

Applicant
David L. Johnson et al.

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Group Art Unit
Not yet assigned

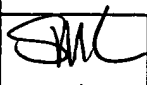
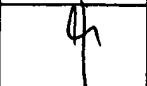
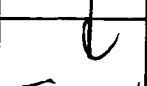
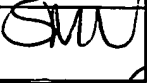
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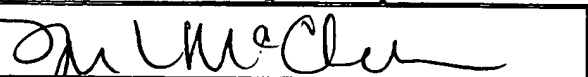
Examiner Initial	Document Number	Date	Name	Class	Sub Class	Translation

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	Emmanouil Spyrou, <u>Radiation initiated cationic polymerization with tailor-made polyesters</u> 43 Progress in Organic Coatings 25-31 (2001)
	Ramamurti N. Kumar et al., <u>Application of Real Time FTIR and MAS NMR Spectroscopy to the Characterization of UV/EB Cured Epoxidized Natural Rubber Blends</u> 286 Macromol. Mater. Eng. 598-604 (2001)
	Christian Decker et al., <u>Photoinitiated cationic polymerization of epoxides</u> 50 Polym. Int'l 986-997 (2001)
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